



Characterisation on Neutron-Irradiated Deep Diffused APDs

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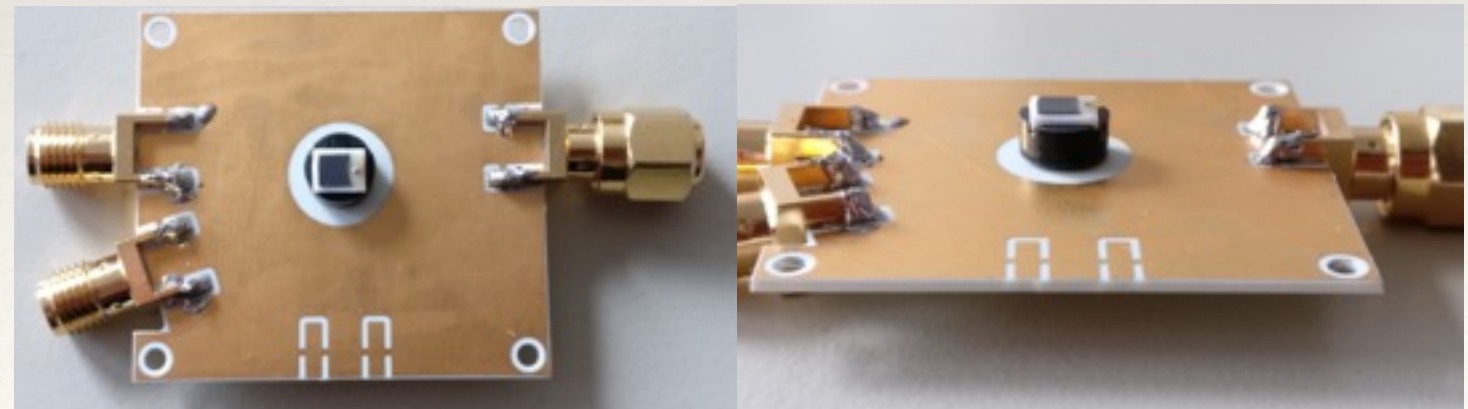
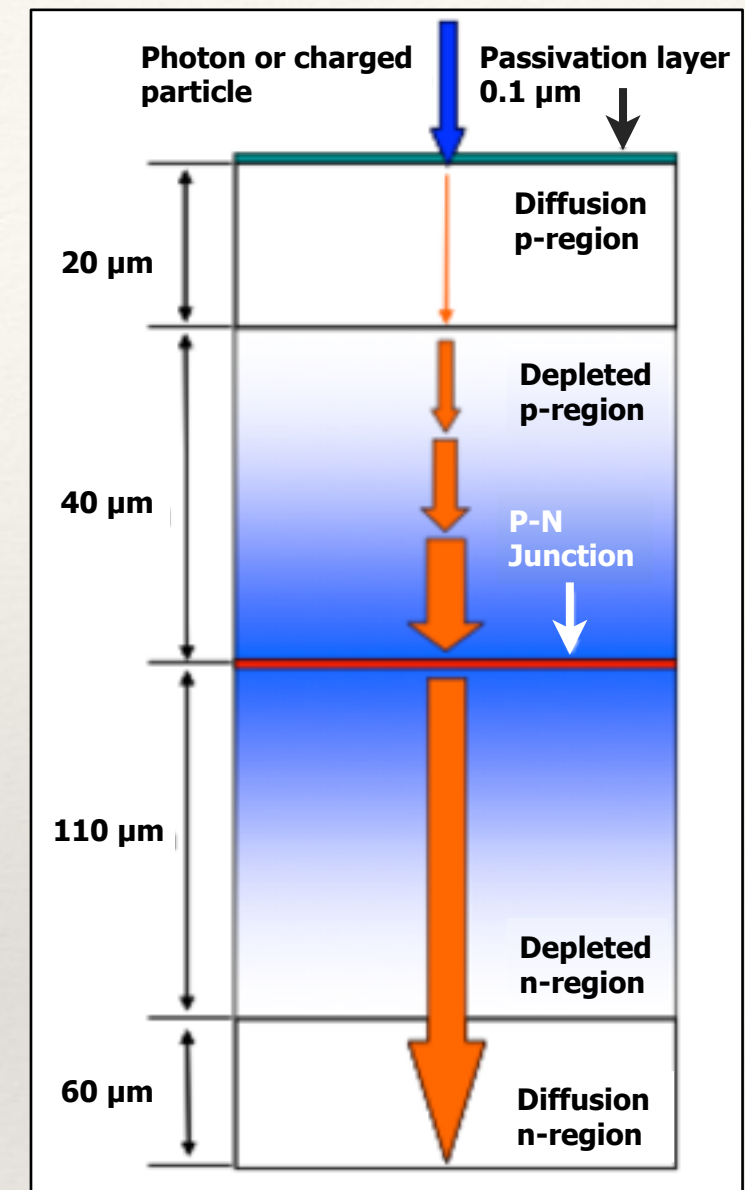
Deep Diffused APDs (DD-APDs).

- ❖ Manufactured by RMD.
- ❖ Amplification deep inside the bulk of the sensor.
- ❖ Requires high voltage (1700 V - 1800 V).
- ❖ Delivers high gain and fast response time

See M. Centis Vignali, 31st RD50 Workshop.

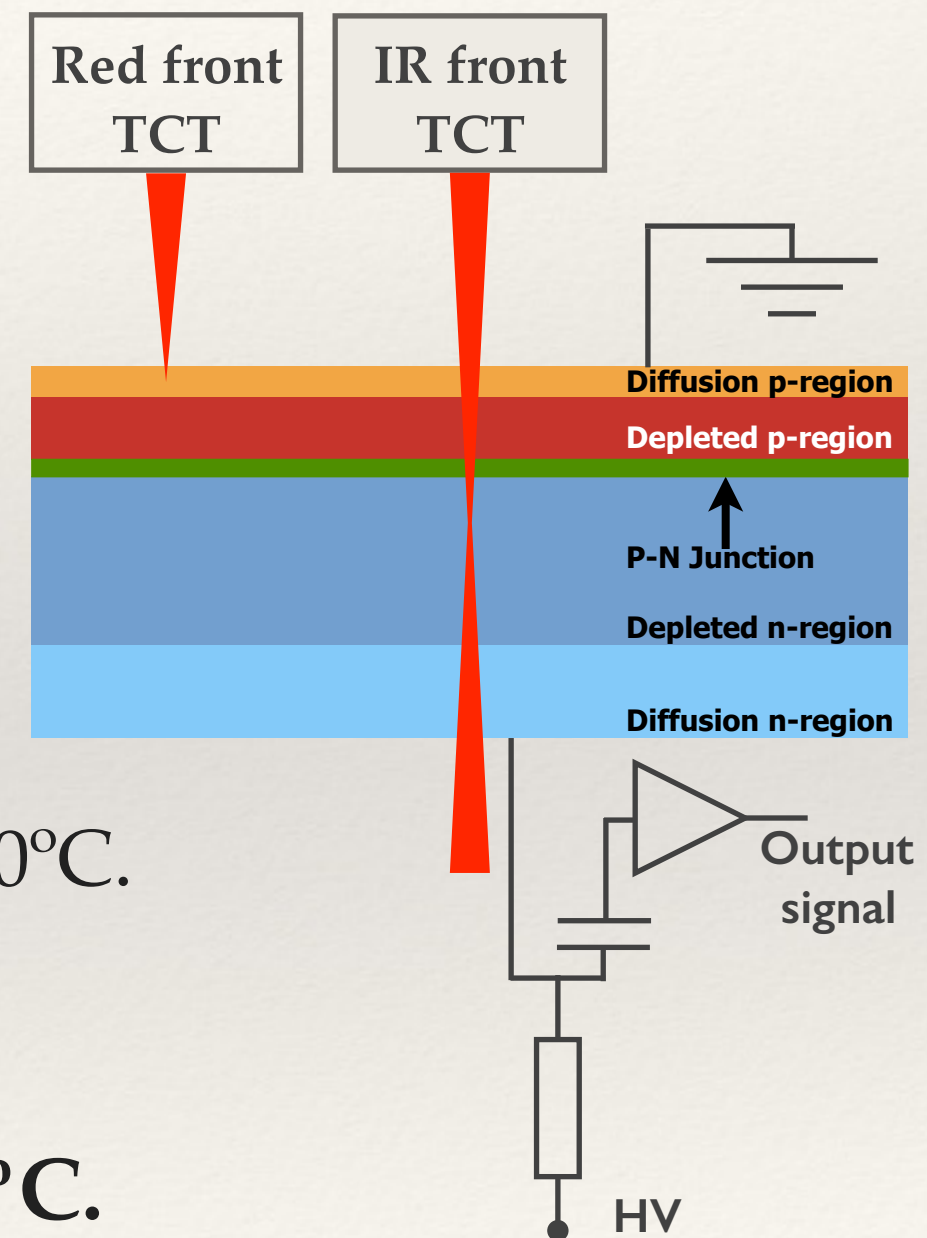
8 devices.

- ❖ Sent to Ljubljana for neutron irradiation.
- ❖ 2 samples per fluence.
 - ❖ $3 \times 10^{13} \text{ n/cm}^2$.
 - ❖ $6 \times 10^{13} \text{ n/cm}^2$.
 - ❖ $3 \times 10^{14} \text{ n/cm}^2$.
 - ❖ $1 \times 10^{15} \text{ n/cm}^2$.



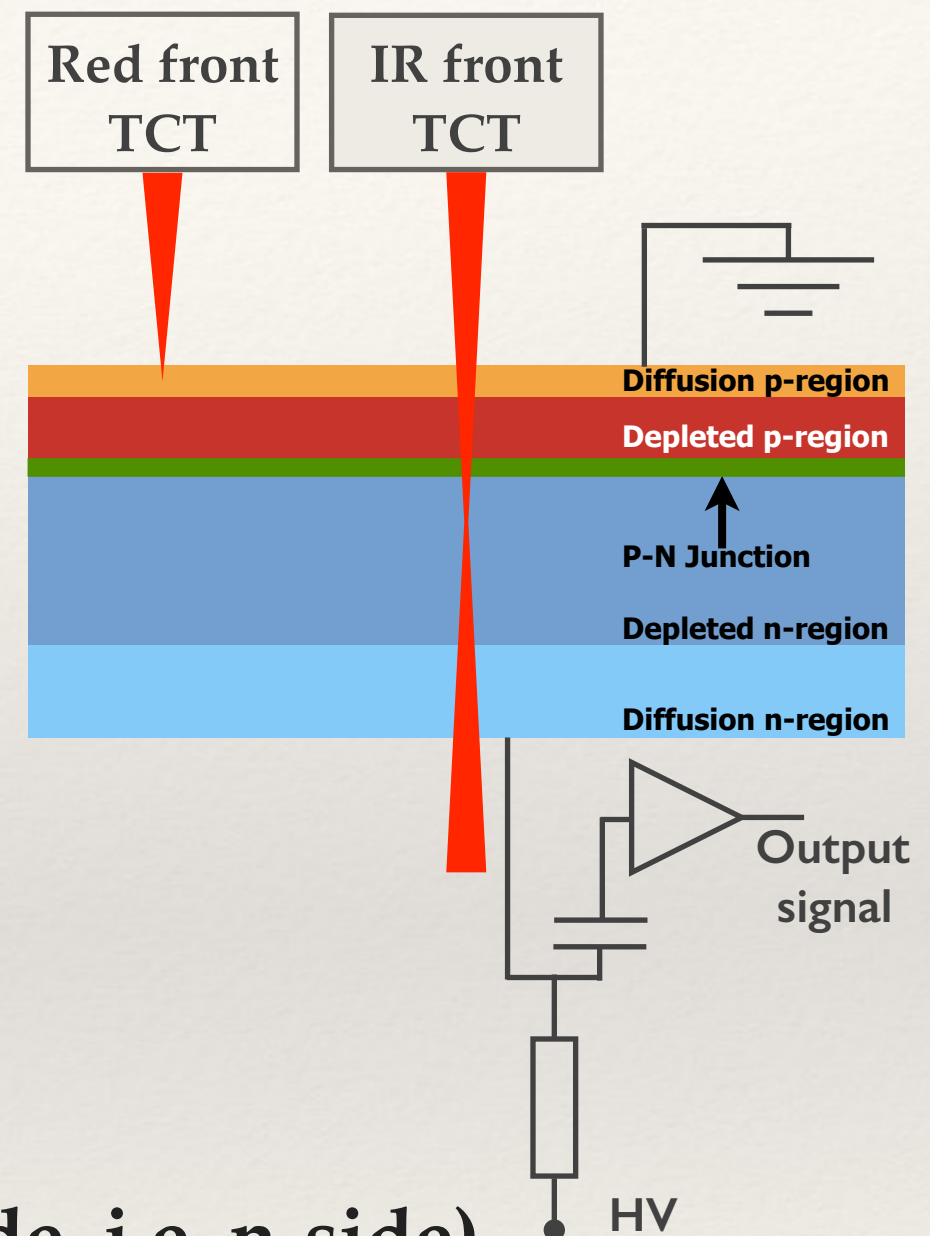
Before and after irradiation for all samples.

- ❖ **Transient Current Technique (TCT).**
 - ❖ **XY scans.**
 - ❖ Red and IR front illumination.
- ❖ **Voltage scans.**
 - ❖ Red and IR front illumination.
- ❖ All TCT measurements were done at -20°C .
- ❖ **CV at -20°C .**
- ❖ **IV at 20°C , 10°C , 0°C , -10°C , and -20°C .**



Transient Current Technique (TCT)

- ❖ Temperature -20°C .
- ❖ 10 dB effective amplification.
- ❖ 40 dB CIVIDEC amplifier.
 - ❖ Linearity range: ± 1 V output.
- ❖ 30 dB attenuator (before amplifier).
- ❖ Laser intensities (peak power):
 - ❖ Red $\approx 87 \mu\text{W}$.
 - ❖ IR $\approx 129 \mu\text{W}$.
- ❖ Read-out and biasing from the back (cathode, i.e. n-side).
 - ❖ Customised bias T ($C = 4.4 \text{ nF}$; $R = 1 \text{ M}\Omega$).
- ❖ Compliance set to $10 \mu\text{A}$.



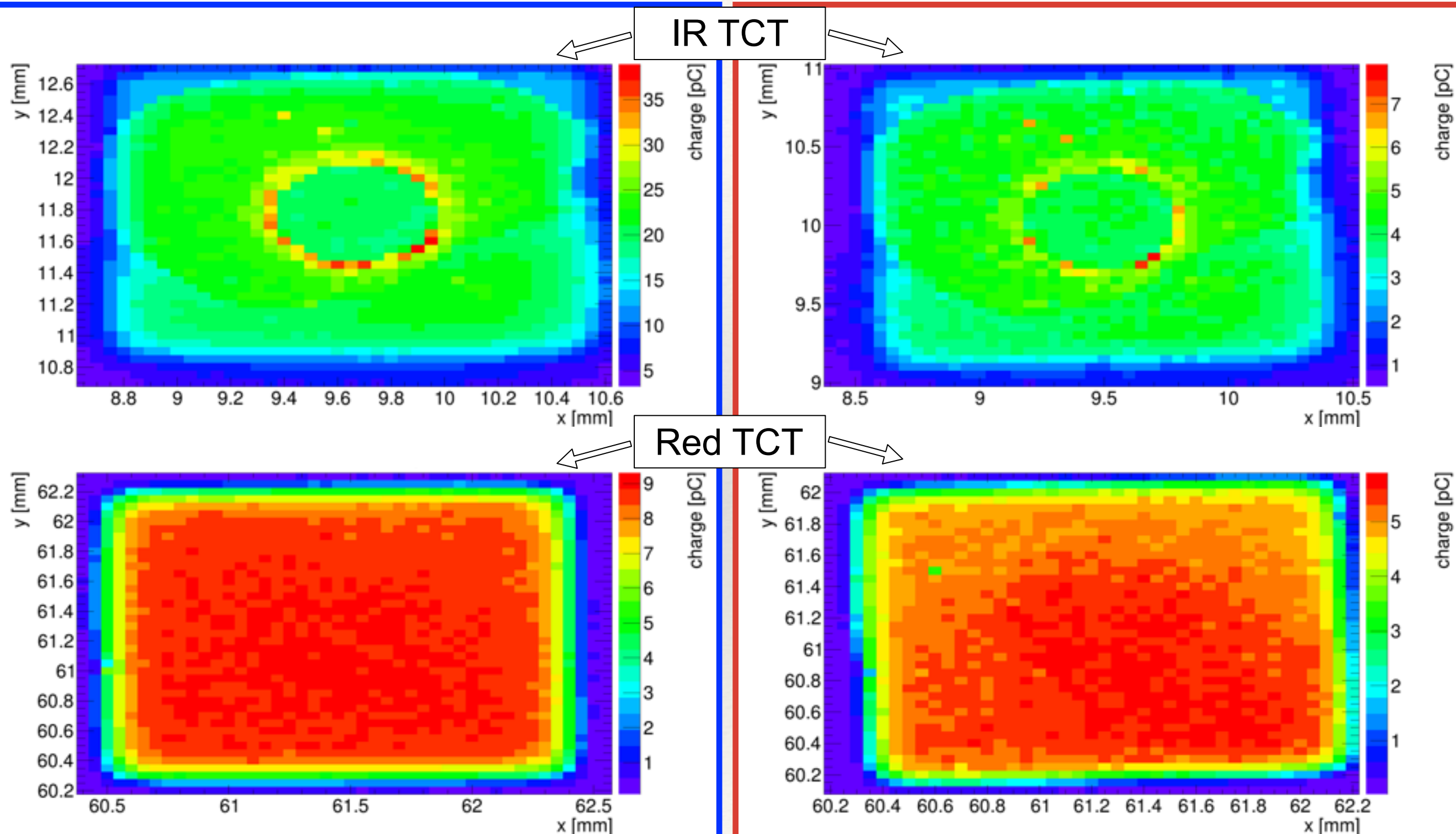


Homogeneity Analysis

Charge collection XY scans

Before irradiation

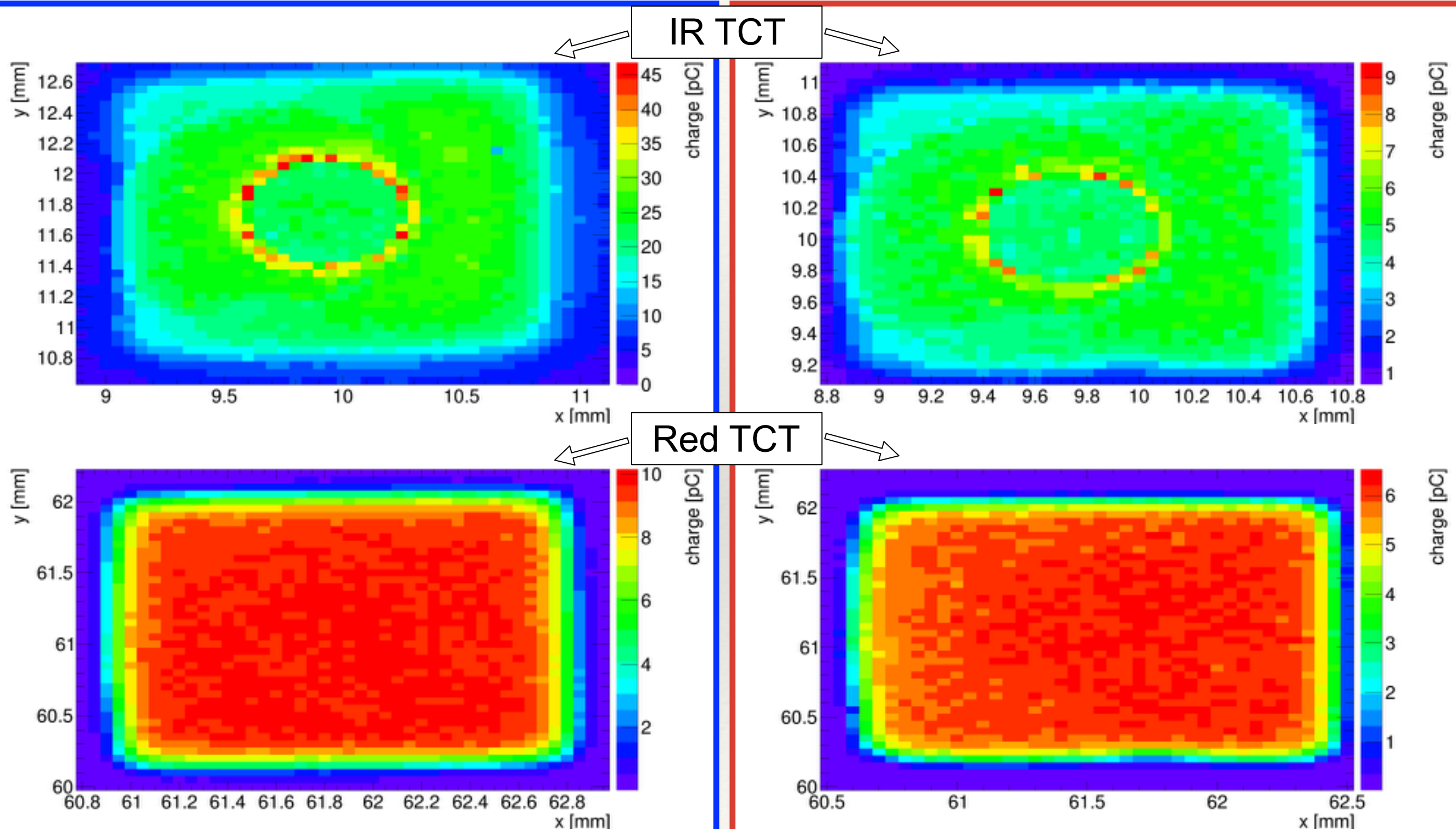
After irradiation $3 \times 10^{13} \text{ n/cm}^2$



Sample: APD_2B_1

Before irradiation

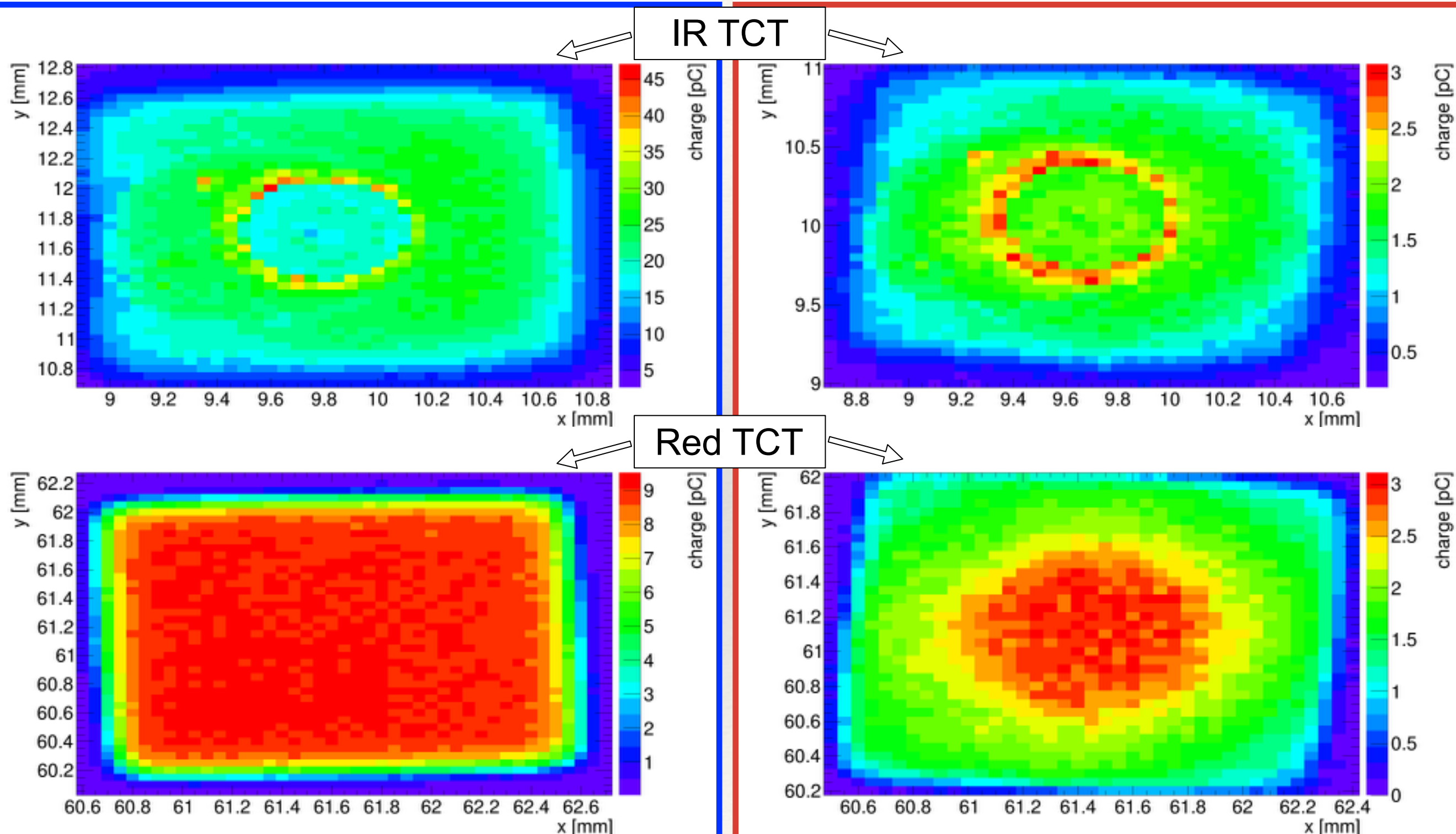
After irradiation $3 \times 10^{13} \text{ n/cm}^2$



Sample: APD_2B_3

Before irradiation

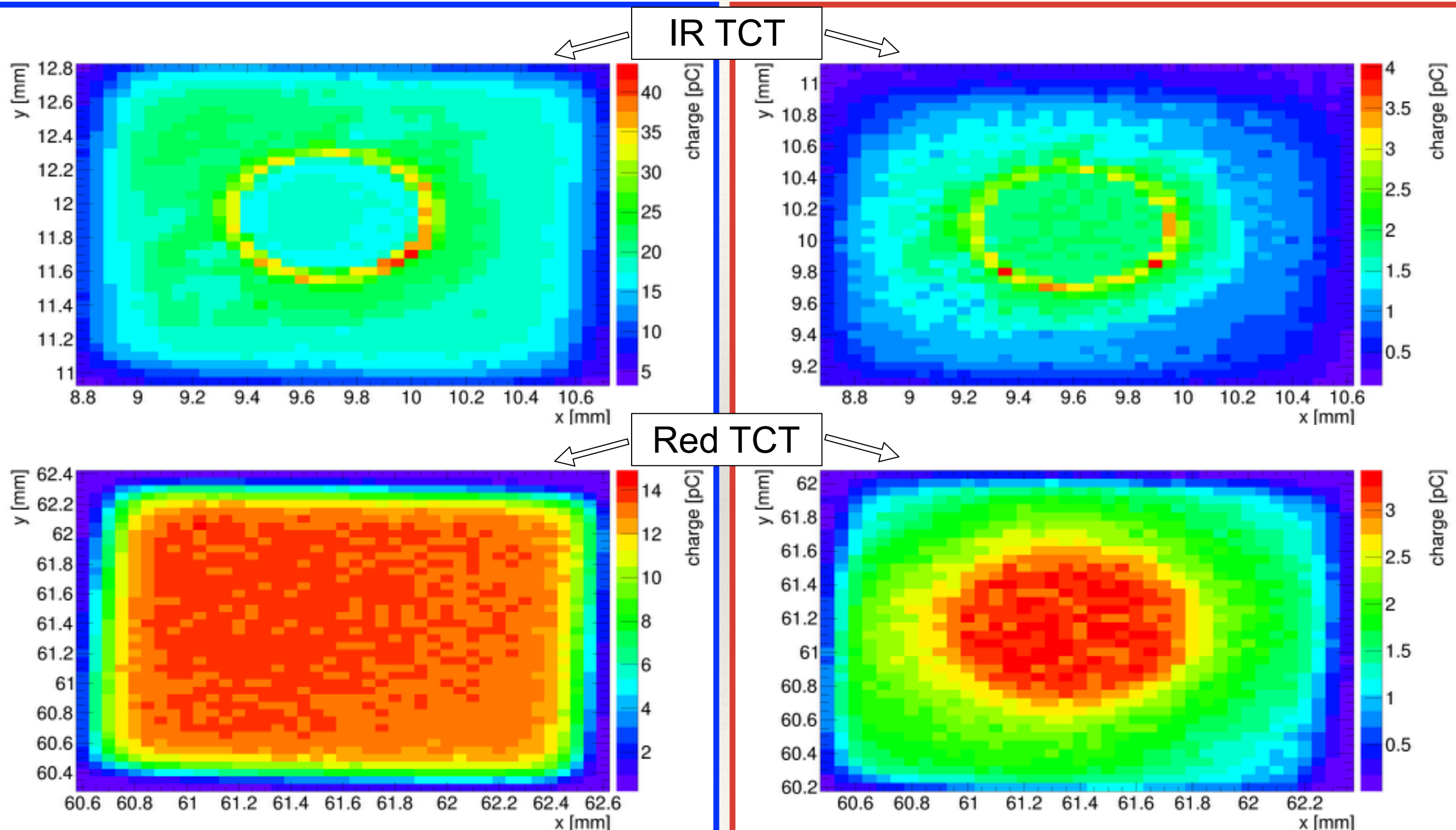
After irradiation $6 \times 10^{13} \text{ n/cm}^2$



Sample: APD_2B_5

Before irradiation

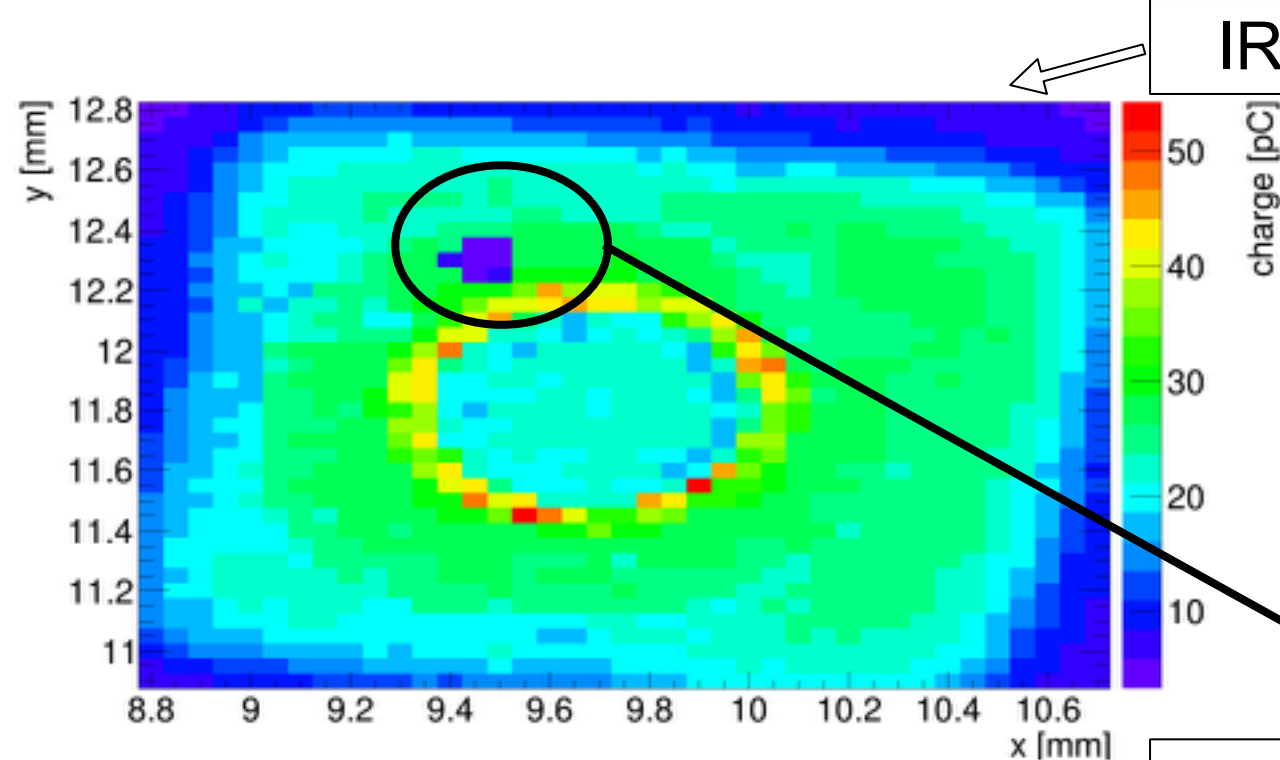
After irradiation $6 \times 10^{13} \text{ n/cm}^2$



Sample: APD_2B_11

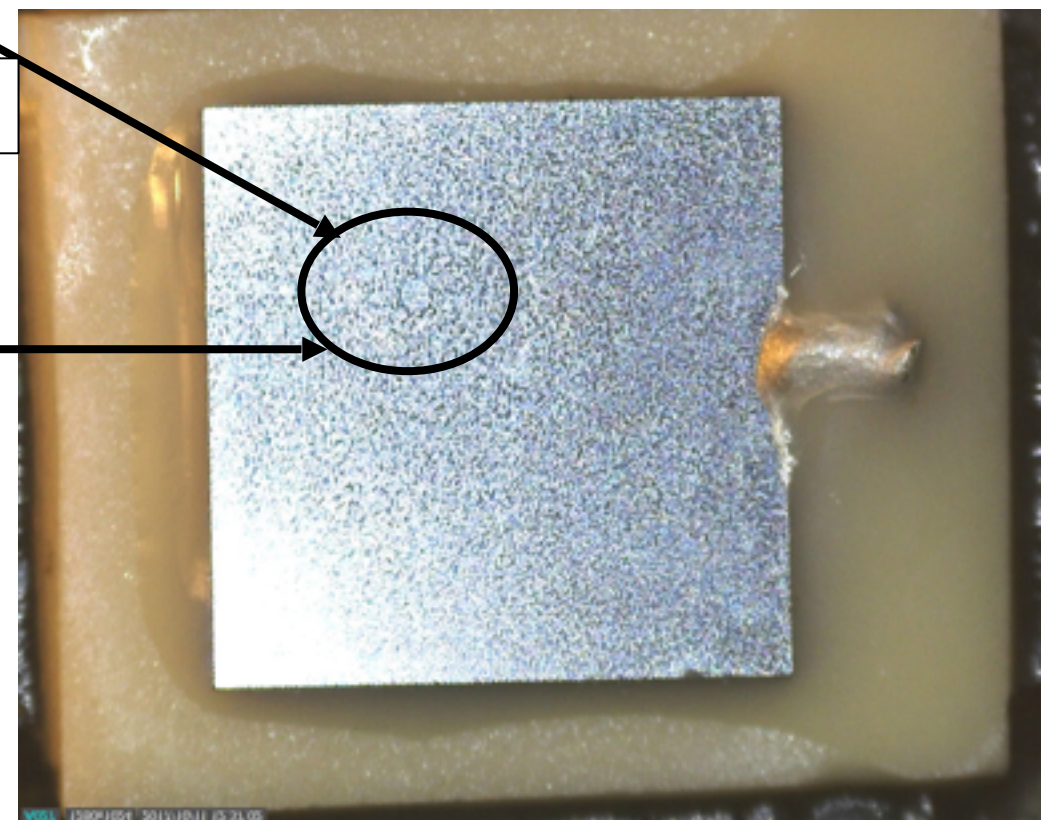
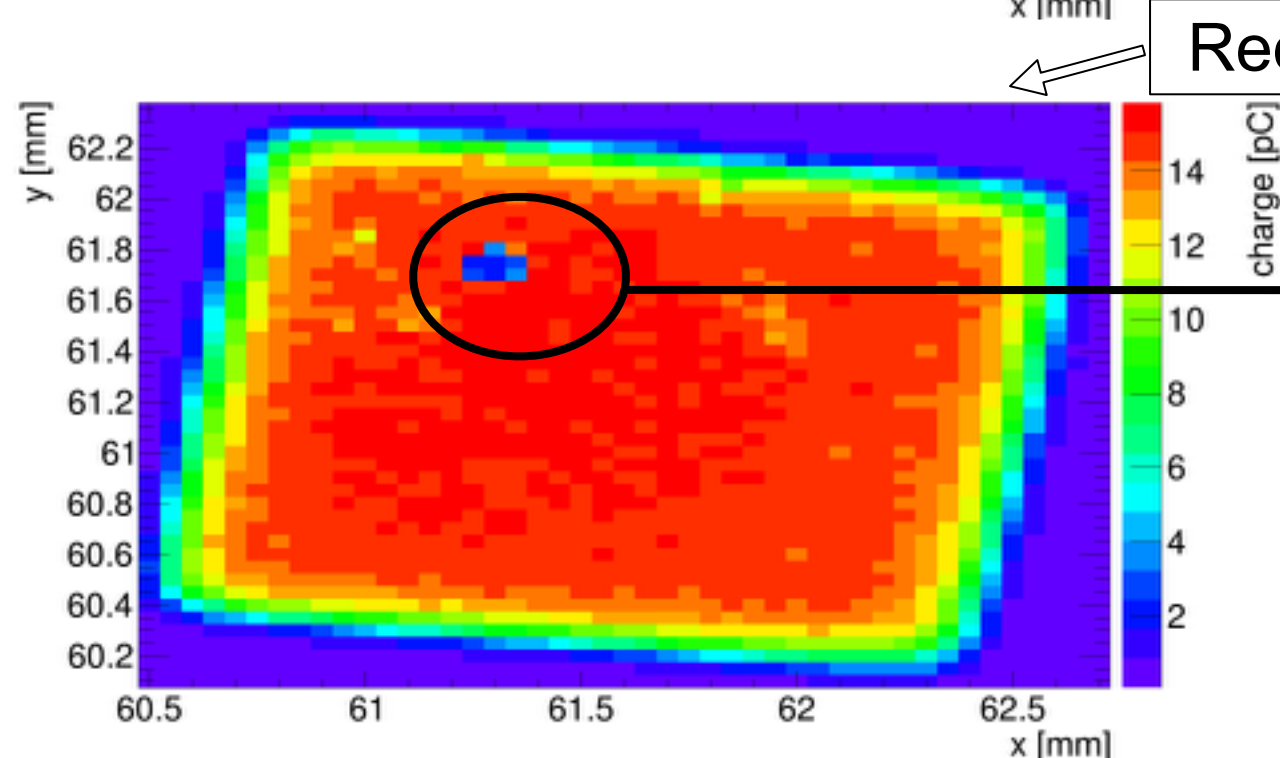
Before irradiation

After irradiation $3 \times 10^{14} \text{ n/cm}^2$



Impossible to perform the measurements.

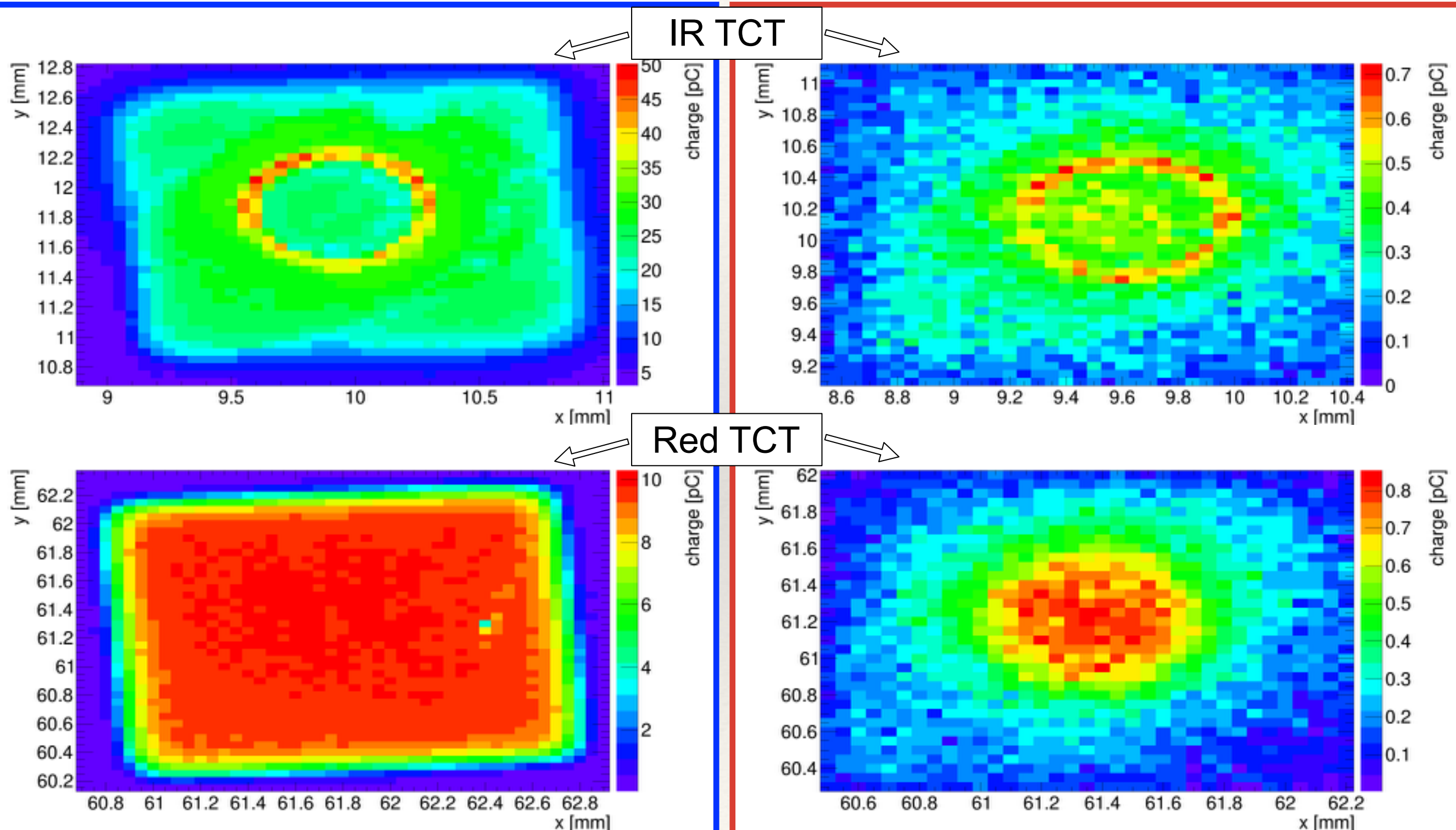
❖ Leakage current $> 1.5 \text{ mA}$ at 7 V.



Sample: APD_2B_6

Before irradiation

After irradiation $3 \times 10^{14} \text{ n/cm}^2$



Sample: APD_2B_4

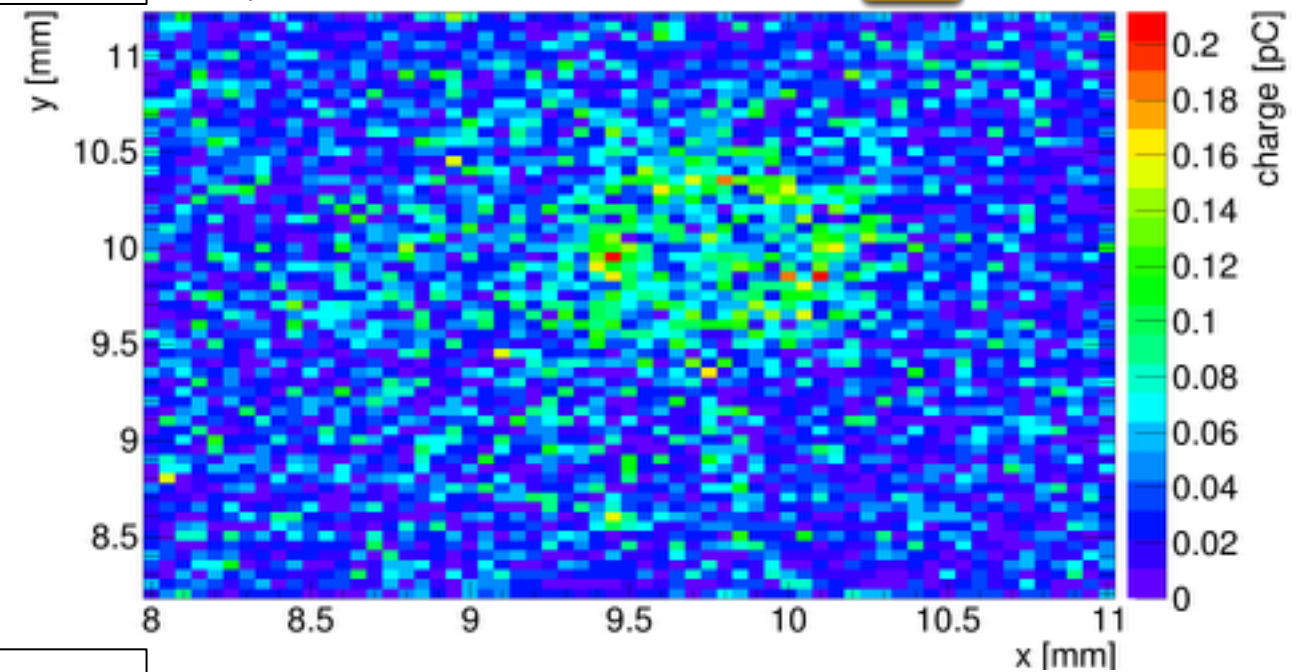
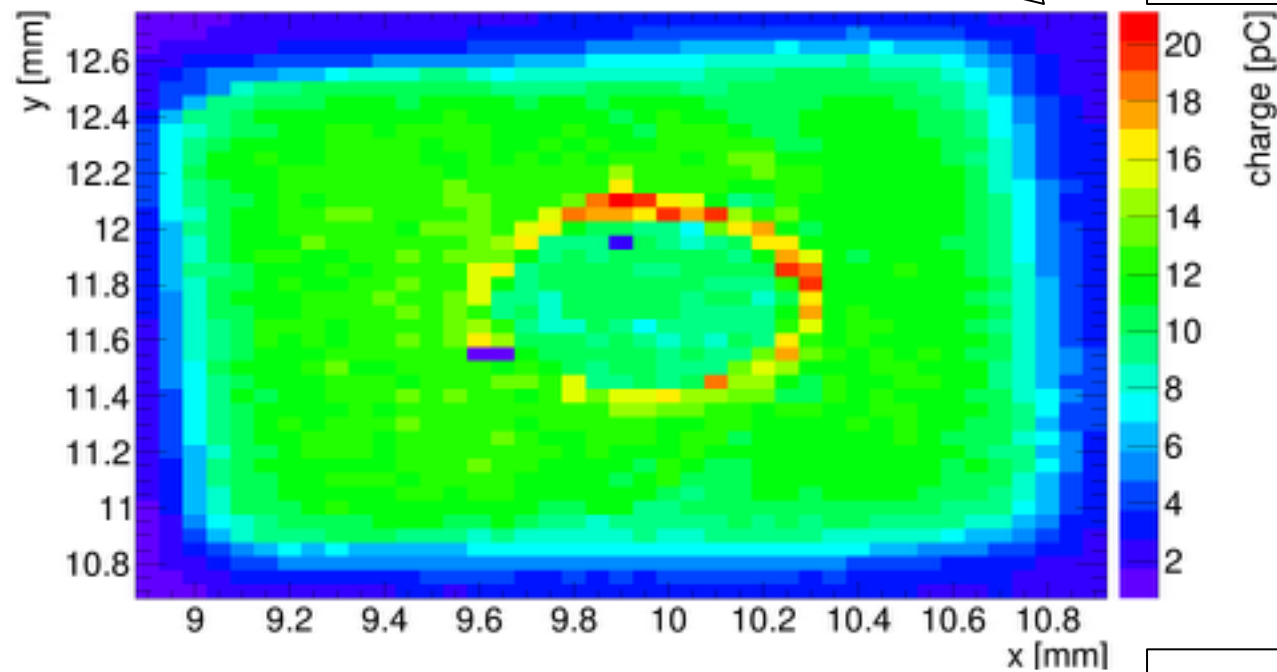
Before irradiation

After irradiation $1 \times 10^{15} \text{ n/cm}^2$

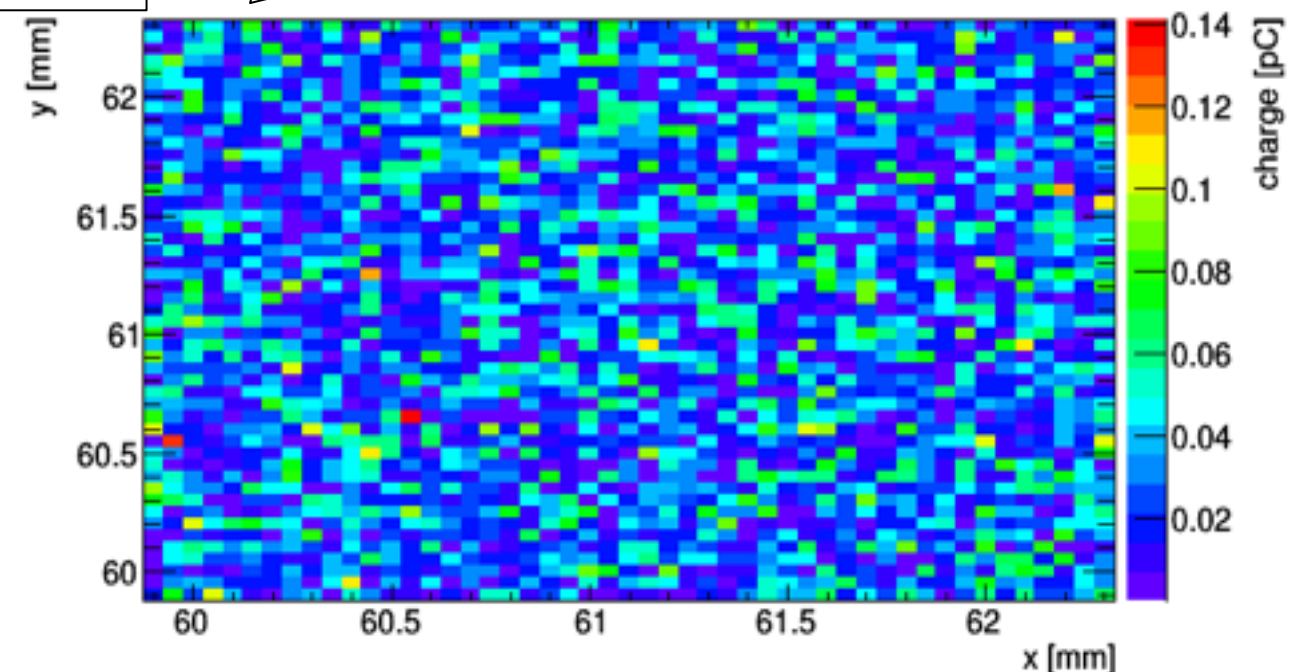
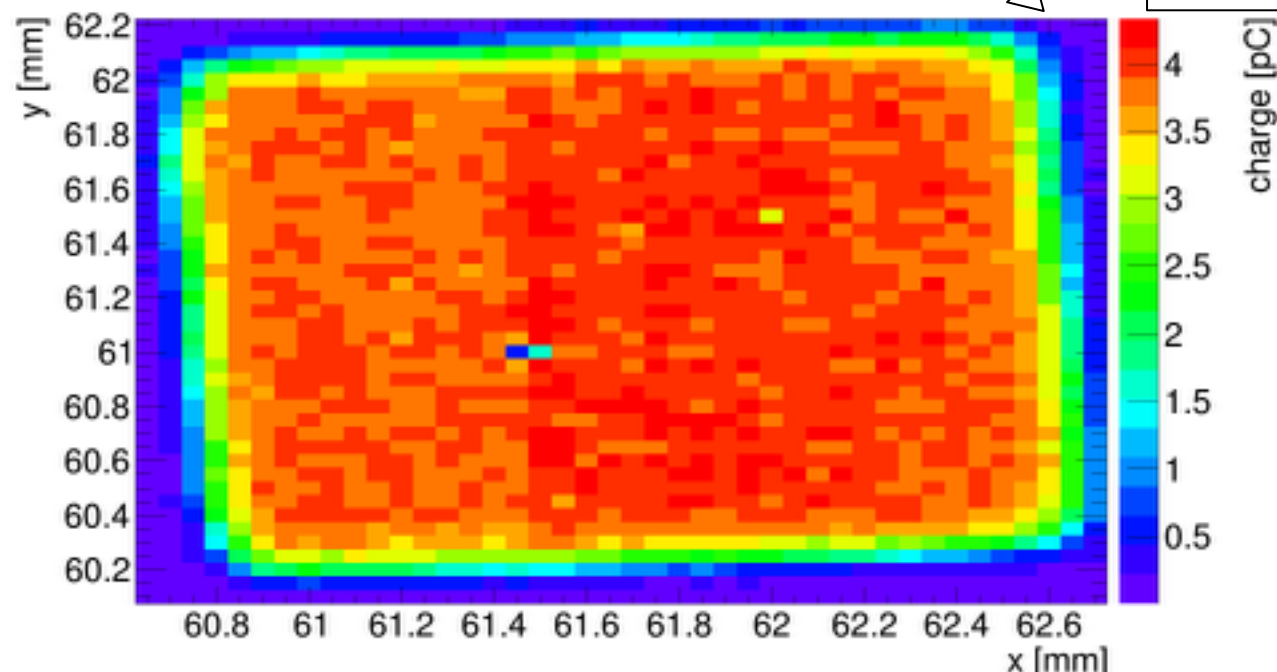
1700 V

IR TCT

450 V* 



Red TCT

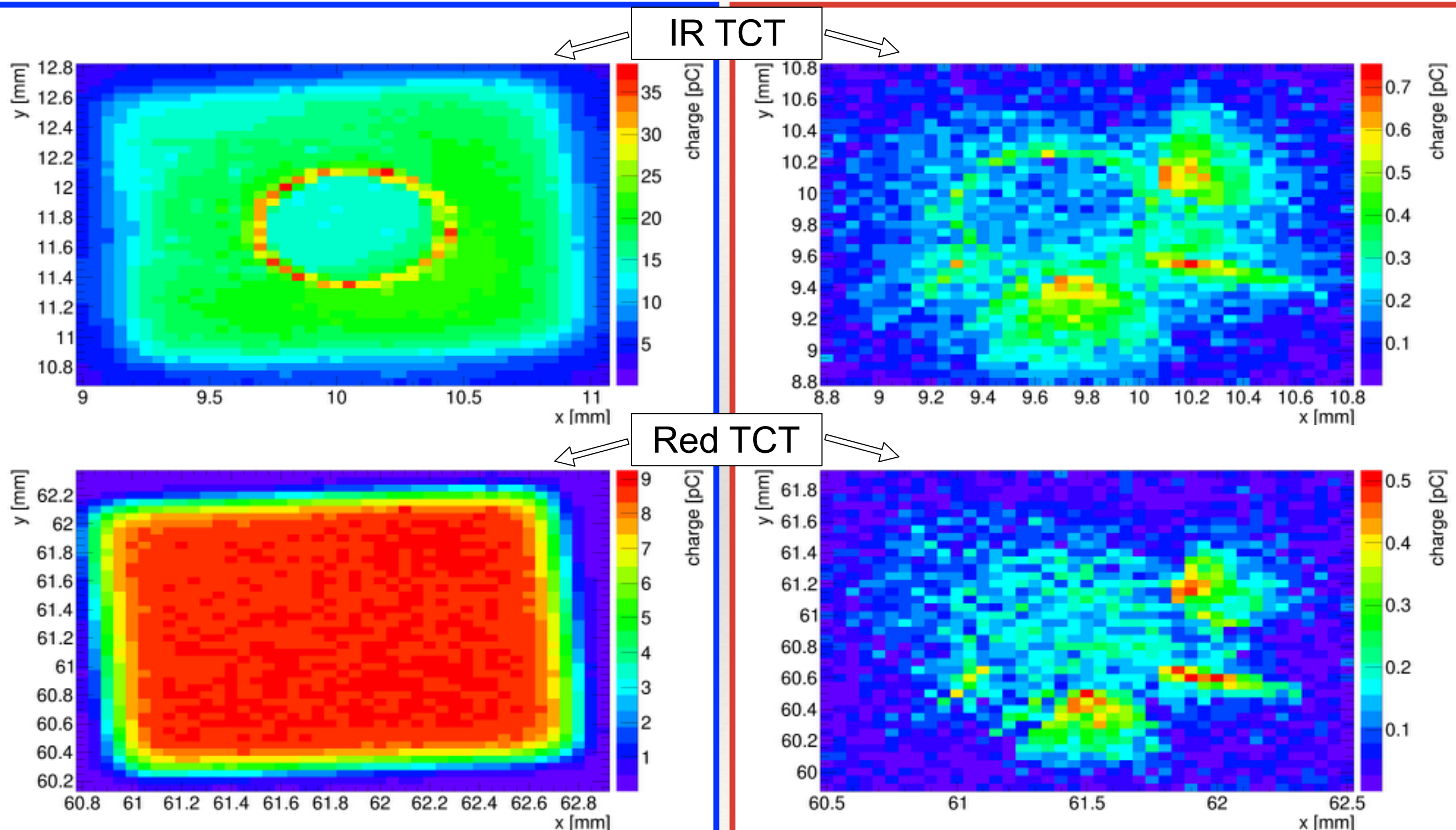


Sample: APD_2B_7

*Reached compliance at $\sim 480 \text{ V}$.

Before irradiation

After irradiation $1 \times 10^{15} \text{ n/cm}^2$



Sample: APD_2B_9



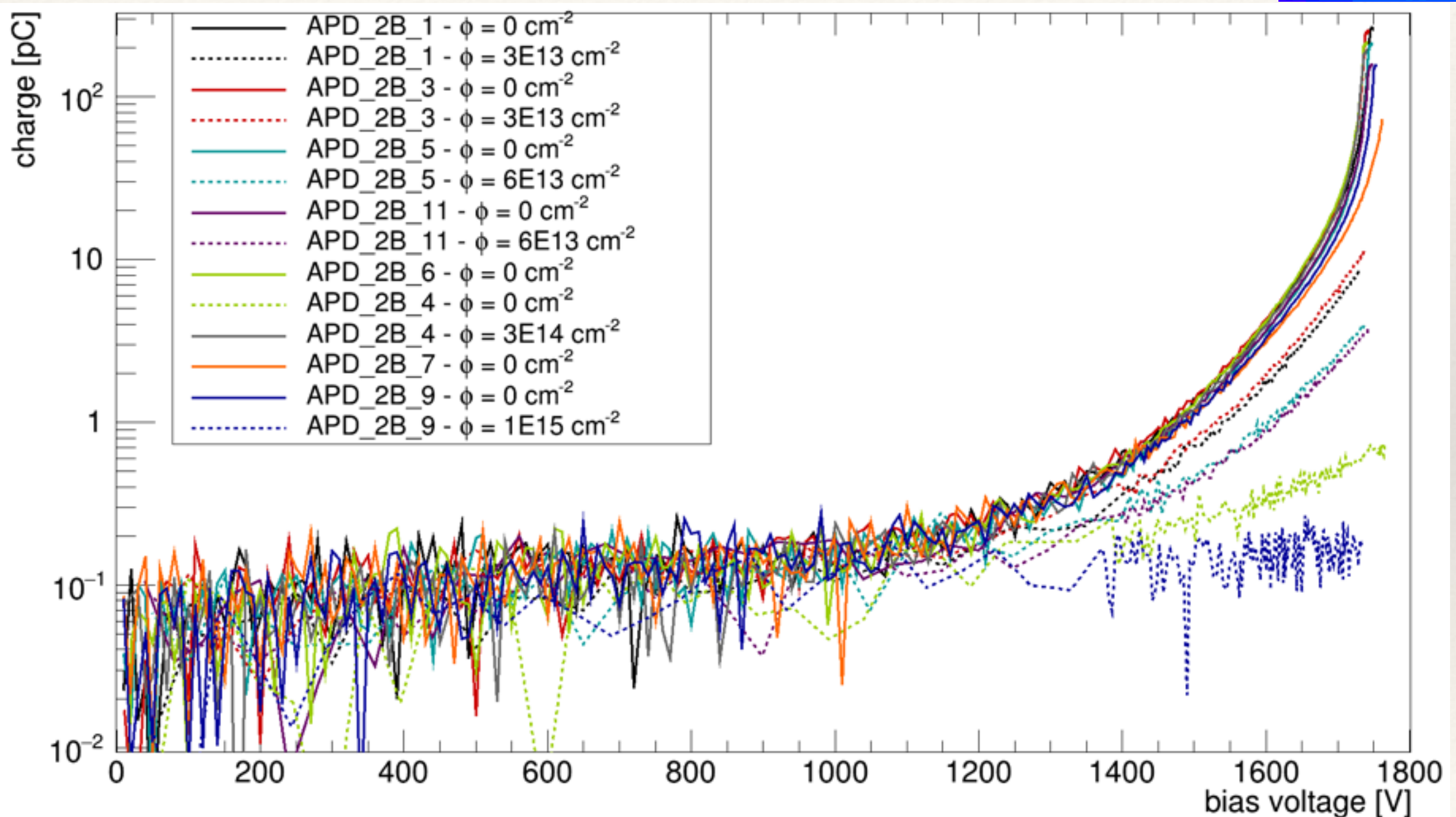
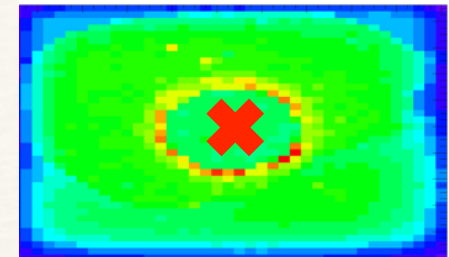
TCT Voltage Scans

Charge collection vs. bias voltage

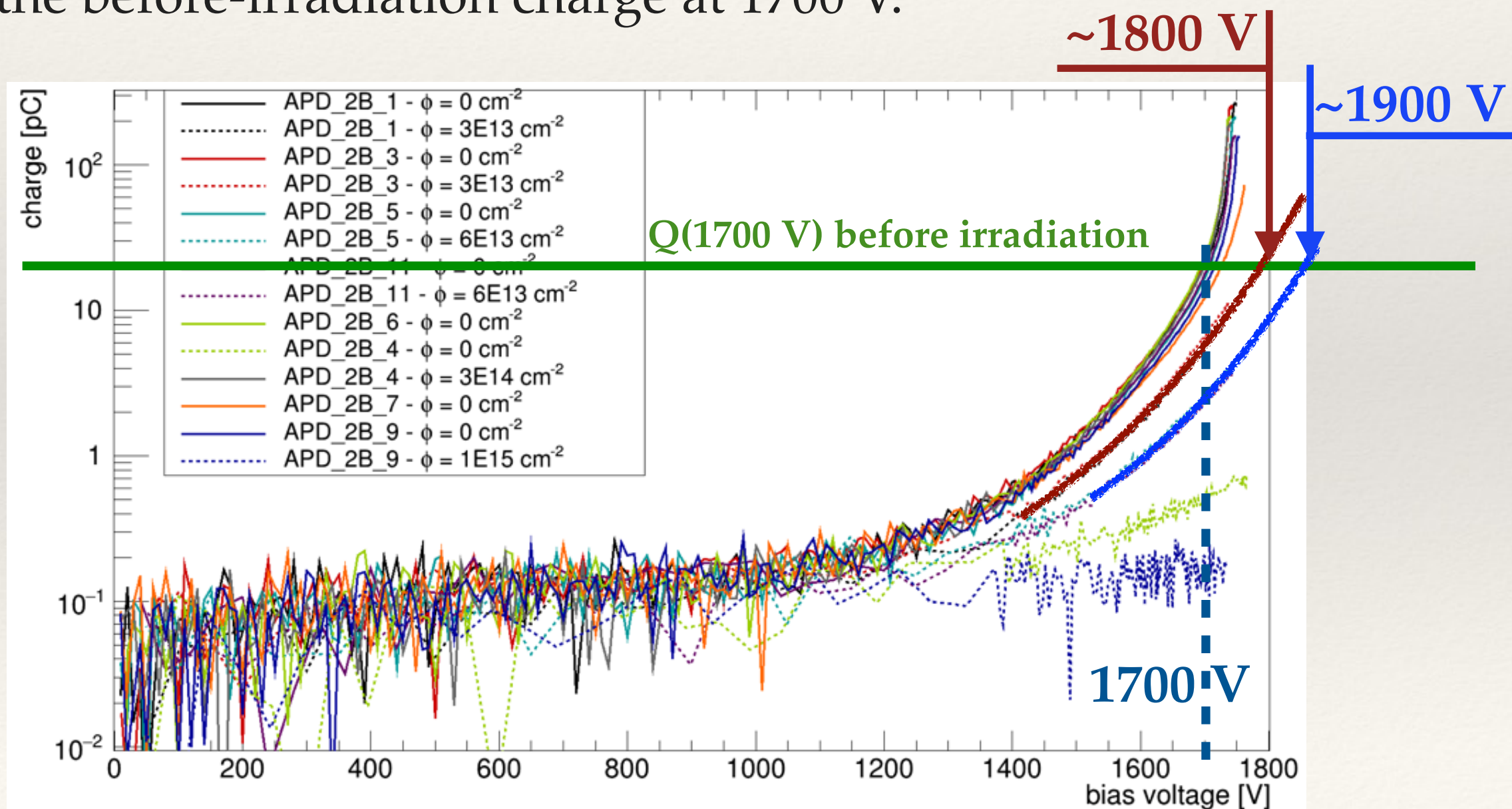
Only voltage scans with IR illumination will be shown.

Red illumination voltage scans can be found in the backup slides.

- ❖ Measurements before and after irradiation.
- ❖ Fixed illumination position.



- ❖ Up to $\phi = 6 \times 10^{13} \text{ n/cm}^2$ charge collection can be recovered by increasing the voltage.
- ❖ For $\phi = 1 \times 10^{15} \text{ n/cm}^2$ a V_{bias} of $\sim 8000 \text{ V}$ would be needed to recover the before-irradiation charge at 1700 V .

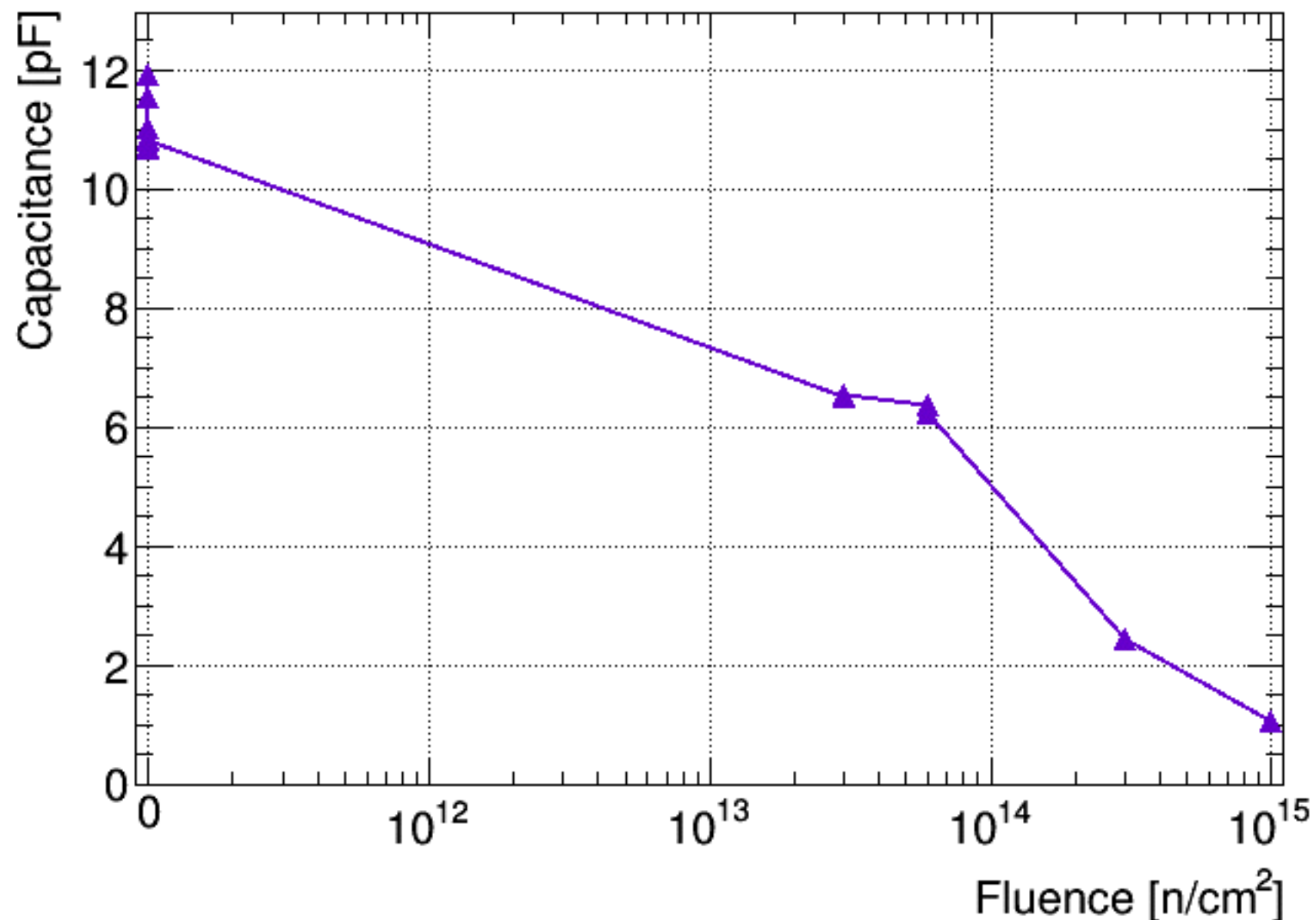




Capacitance vs. Fluence

- ❖ Measurements before and after irradiation for all samples.
- ❖ Capacitance decreases with fluence.
- ❖ Indicative of an increase in thickness of the depletion region.

- ❖ $V_{\text{bias}} = 500 \text{ V}$.
- ❖ $f = 10 \text{ kHz}$.
- ❖ $T = -20^\circ\text{C}$.
- ❖ Back biasing (n-side).



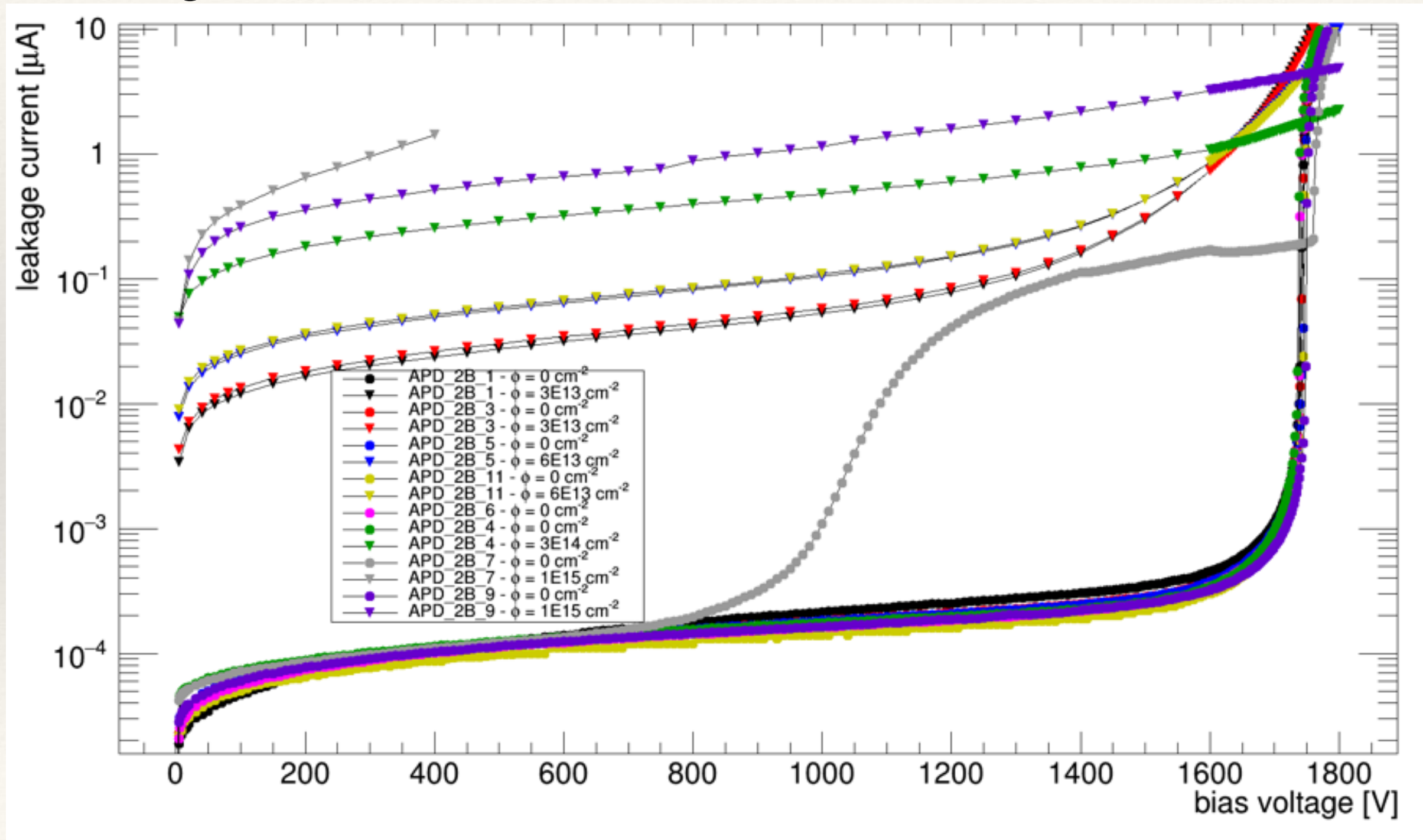


Leakage Current Measurements

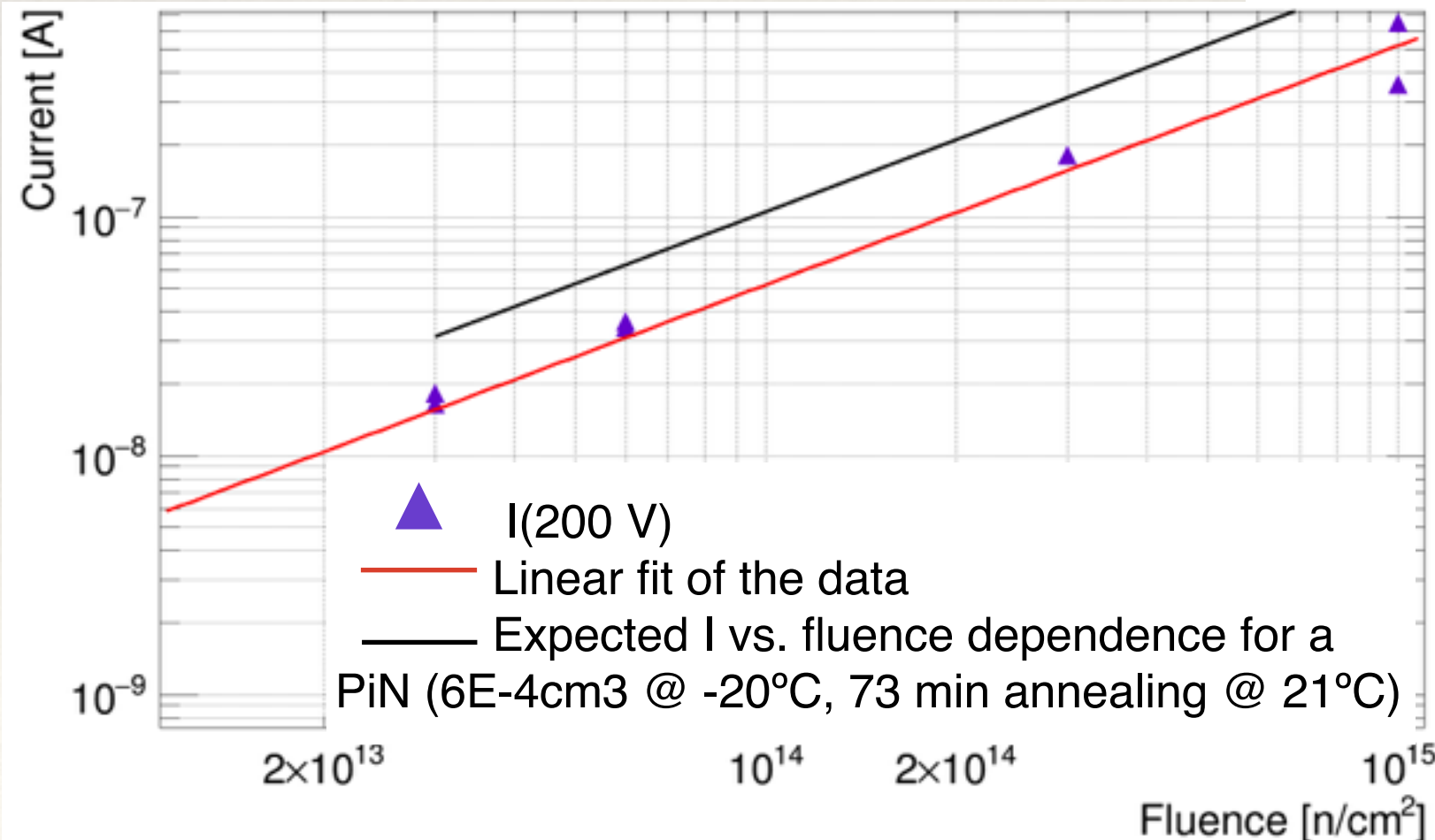
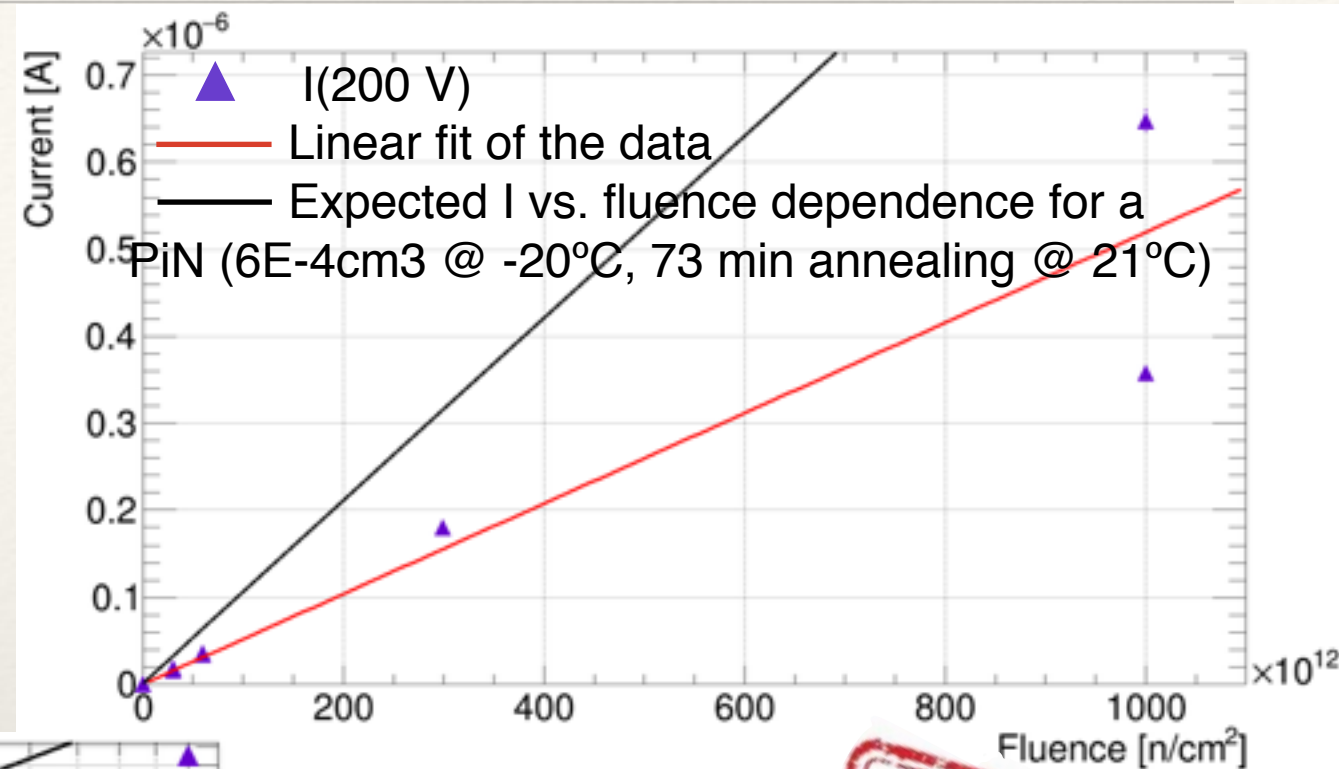
- ❖ **Measurements before and after irradiation for all samples.**
- ❖ **Temperatures:**
 - ❖ **20°C, 10°C, 0°C, -10°C, and -20°C.**
- ❖ **Back biasing (cathode, i.e. n-side).**
- ❖ **Compliance 10 μ A.**

IV curves at -20°C

- ❖ Before irradiation all samples, but one, behave similarly.
- ❖ Leakage current increases with fluence.



- ❖ Leakage current at 200 V (no gain).
- ❖ Estimated average annealing time:
 - ❖ 73 min at 21°C.
- ❖ Dimensions assumed: $6 \times 10^{-4} \text{ cm}^3$.
 - ❖ $A = 2 \times 2 \text{ mm}^2$, $d = 150 \text{ }\mu\text{m}$.

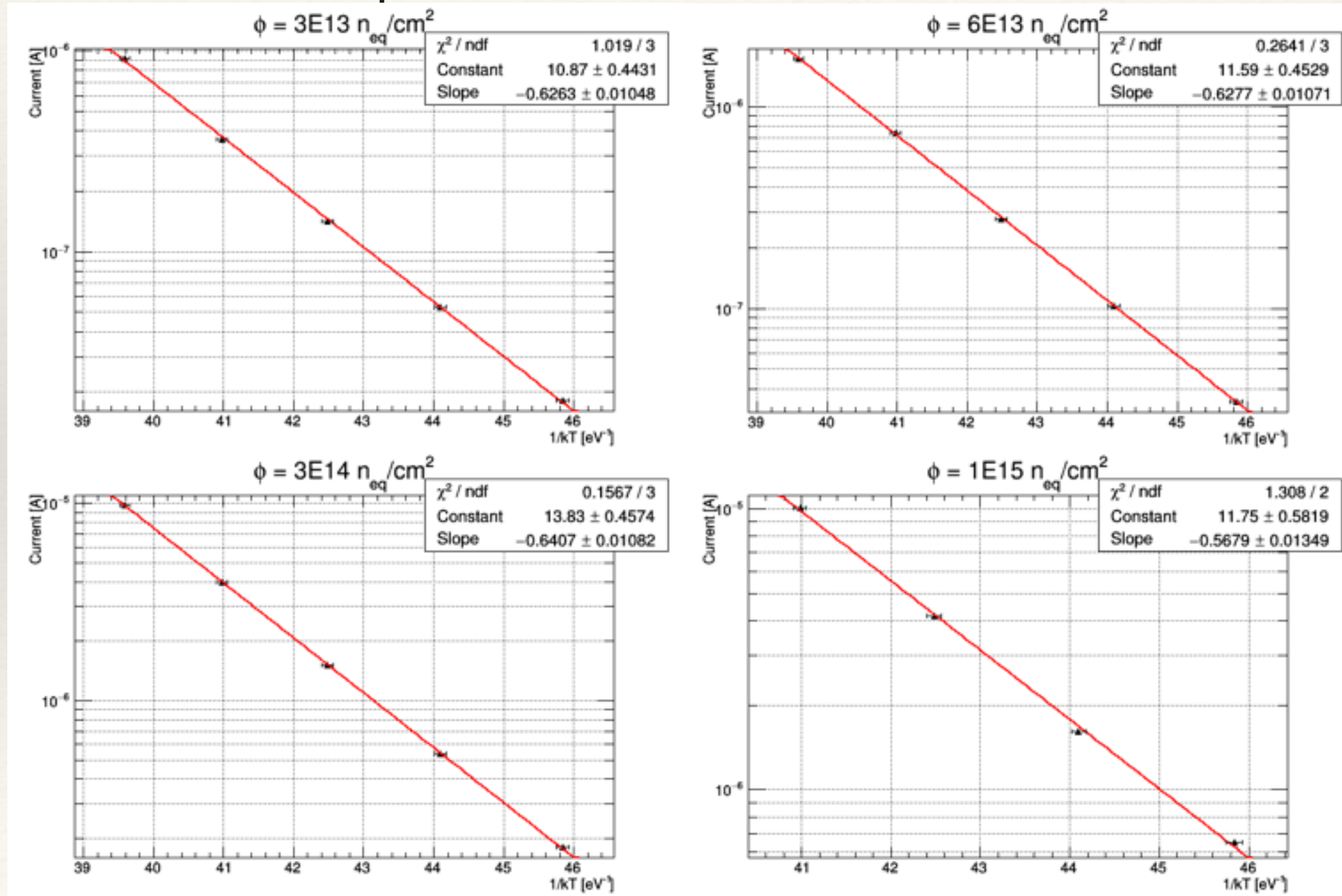


ESTIMATION
Active volume changes are not being considered.

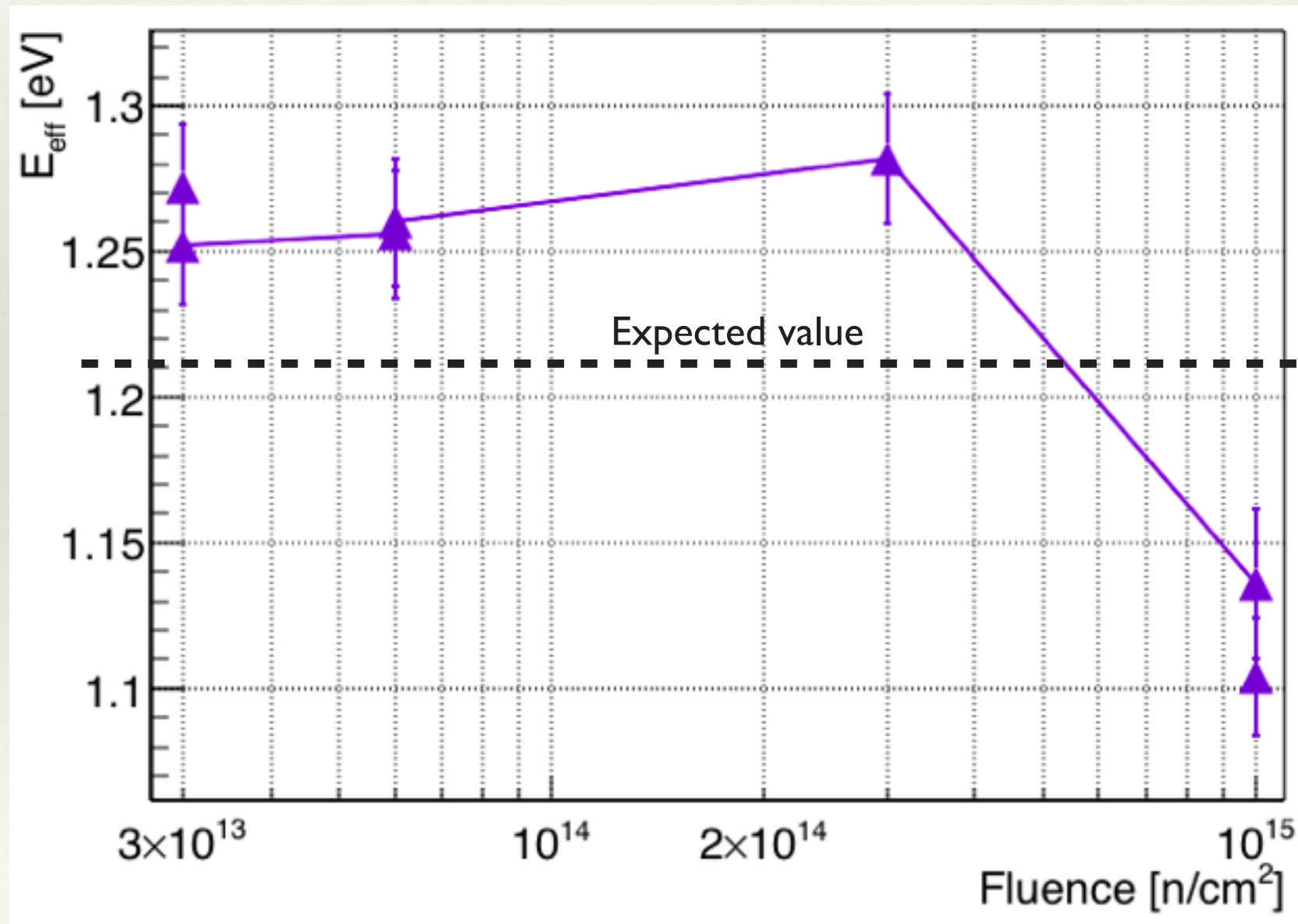
Damage coefficient:

- ❖ From fitting DD-APD data:
 $\alpha_{\text{fit}} \approx 8.66 \times 10^{-19} \text{ A/cm}$
- ❖ For a PiN of equal volume and annealing:
 $\alpha_{\text{PiN}} \approx 17.5 \times 10^{-19} \text{ A/cm}$

- ❖ IV curves were measured at 5 different temperatures.
- ❖ Objective: produce an Arrhenius plot, calculate the effective energy and compare it with the expected value.



- ❖ Fit to: $I(T) \propto T^2 \exp\left(-\frac{E_{eff}}{2kT}\right)$ with $E_{eff} = E_g + 2\Delta$
- ❖ Expected value: $E_{eff} = 1.21$ eV. [2013, A. Chilingarov, JINST 8 P10003]
- ❖ Average and SD over fit results: $E_{eff}^{fit} = (1.22 \pm 0.07)$ eV.



- ❖ XY scans seemingly show a reduction of the active area with fluence.
- ❖ Red-TCT XY scans: central inhomogeneity appears for $\phi \geq 6 \times 10^{13} \text{ n/cm}^2$.
 - ❖ This has yet to be understood.
- ❖ **TCT voltage scans show a decrease in charge collection with fluence.**
 - ❖ For $\phi \geq 6 \times 10^{13} \text{ n/cm}^2$ charge collection can be recovered by increasing V_{bias} .
 - ❖ For $\phi \geq 3 \times 10^{14} \text{ n/cm}^2$ the bias voltage required to recover before-irradiation charge collection levels is beyond reasonable values.
- ❖ From $I(200 \text{ V})$ vs. ϕ , α was estimated: $8.66 \times 10^{-19} \text{ A/cm}$ (expected order of magnitude).
- ❖ Effective energy calculation: $E_{\text{eff}}^{\text{fit}} = (1.22 \pm 0.07) \text{ eV}$.
- ❖ C vs. ϕ data show an increase in the depletion region thickness with fluence.
- ❖ Further studies must be performed for $6 \times 10^{13} \leq \phi \leq 7 \times 10^{14} \text{ n/cm}^2$.

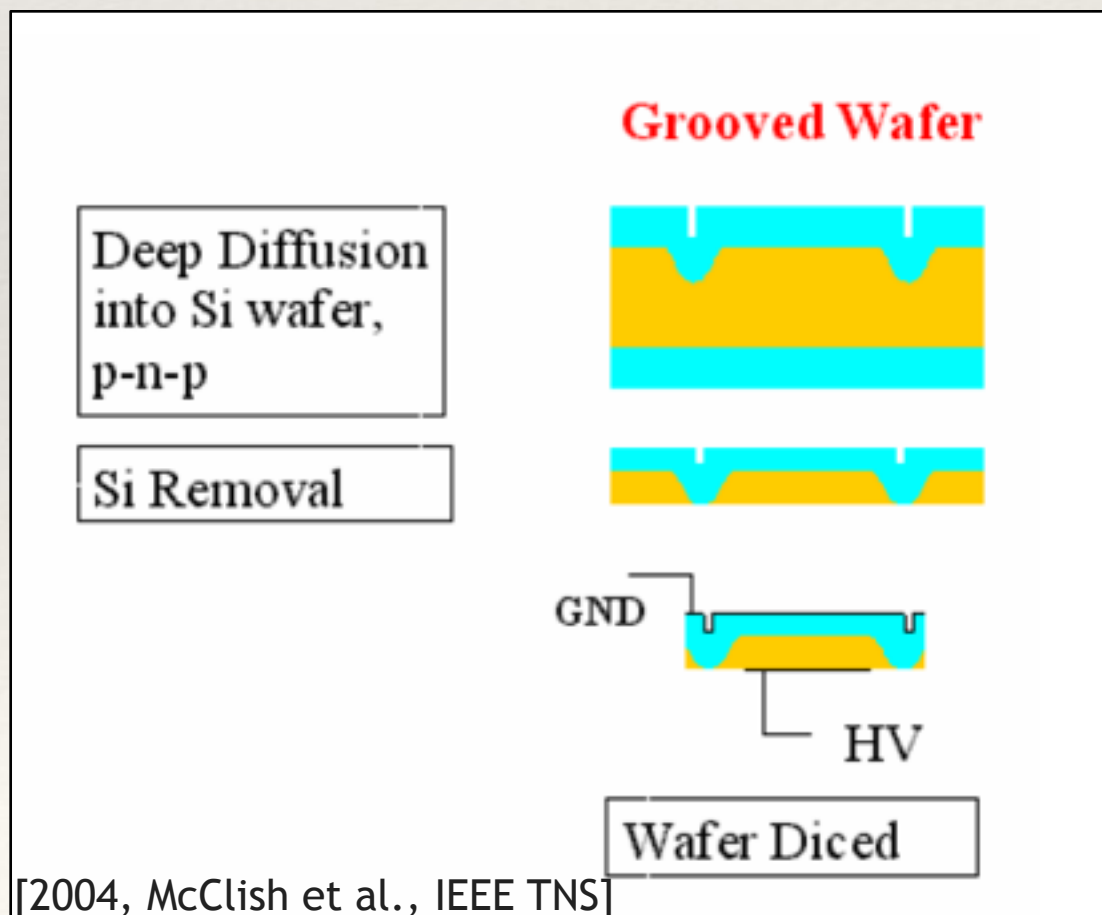


Backup Slides

- ❖ Manufactured by RMD.
- ❖ **Structure:**
 - ❖ n-type NTD-doped silicon (Topsil).
 - ❖ Grooving wafer.
 - ❖ Deep diffusion of p-type dopants.
 - ❖ Gallium used as dopant.
 - ❖ Etching of surface layer.

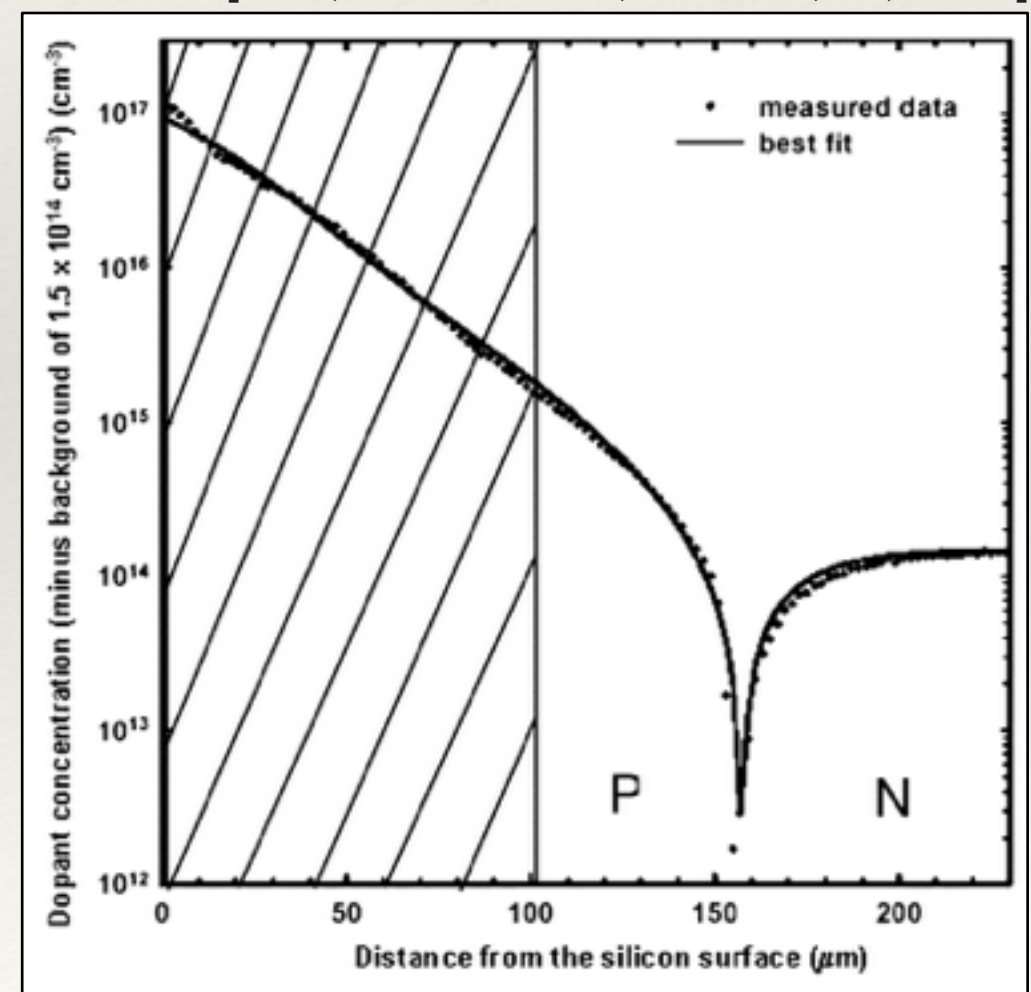
Previous study of neutron-irradiated DD-APDs:

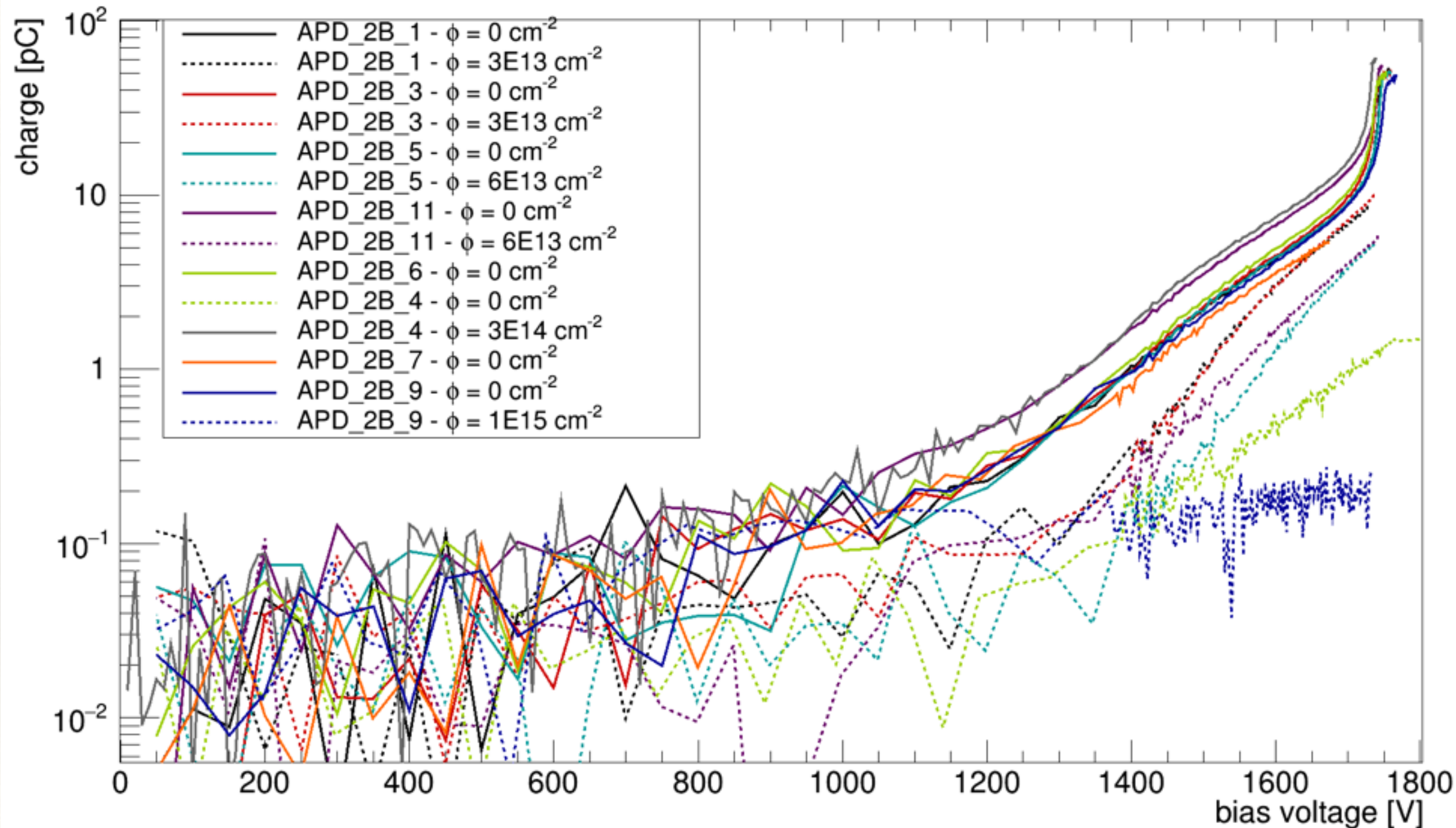
S. Otero Ugobono, Characterisation of HFS Detectors, 29th RD50 Workshop, CERN, November 2016

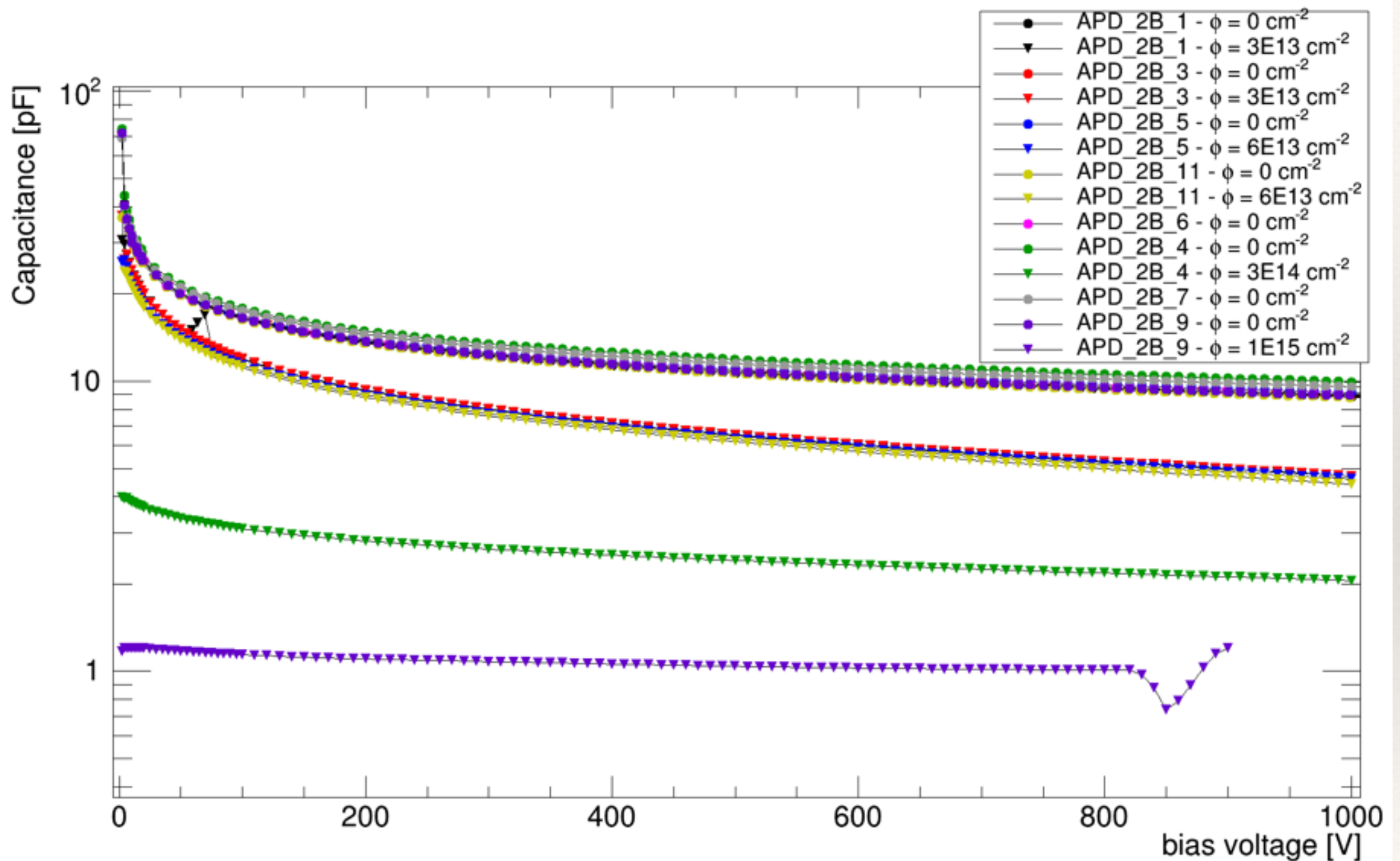


[2004, McClish et al., IEEE TNS]

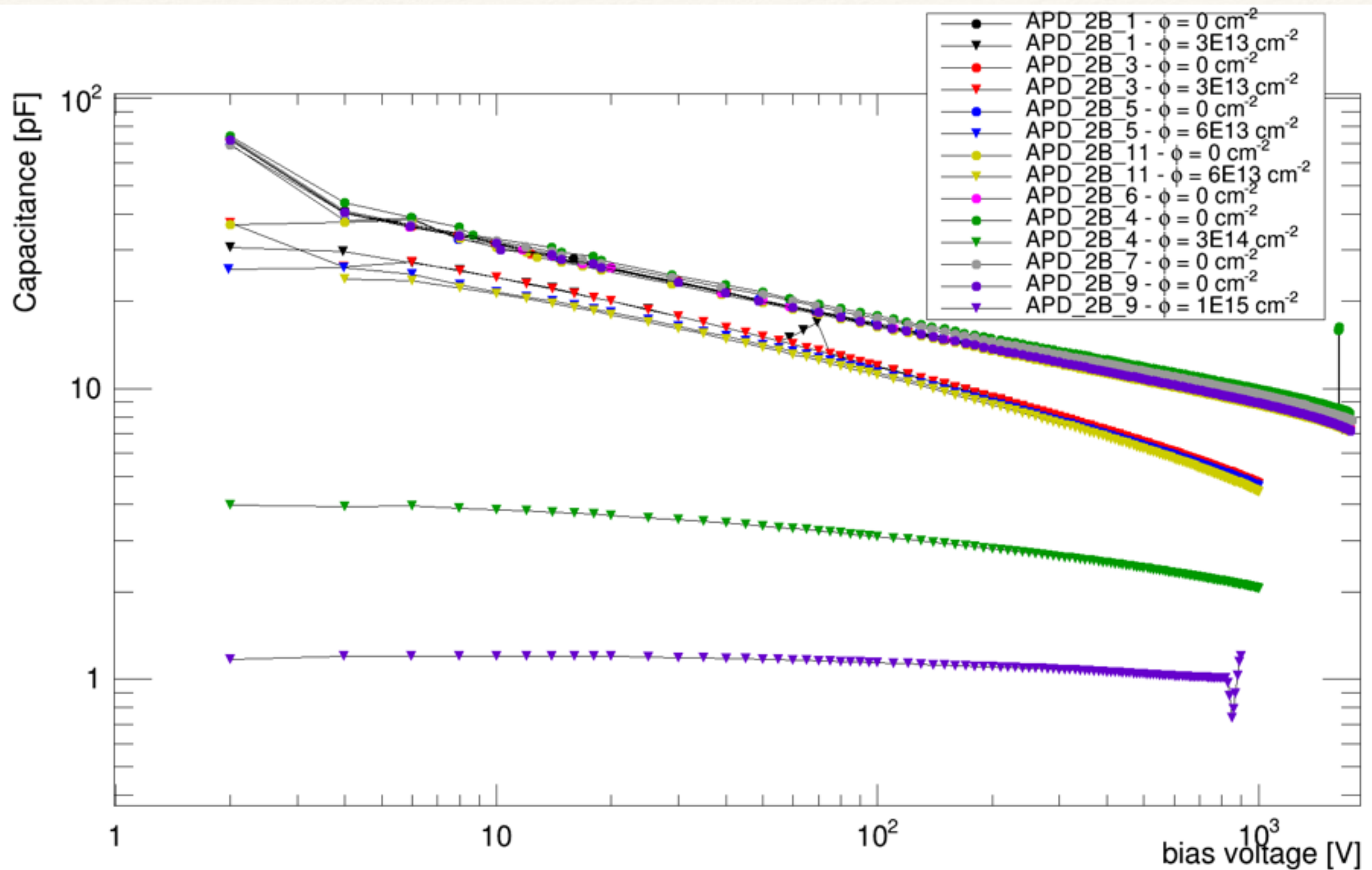
[2006, McClish et al., IEEE TNS, 53, 3049]







CV curves at -20°C





Leakage Current vs. Temperature Plots for all Fluences and Devices

